

Electrode Models under Shape Deformation in Electrical Impedance Tomography

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Motivation

- Using Difference EIT, most unknowns do not affect image quality as long as they are not changing:
 - e.g. contact impedance,
 - electrode area, or
 - electrode location [1]
- ... but what happens when the body *is* deforming?

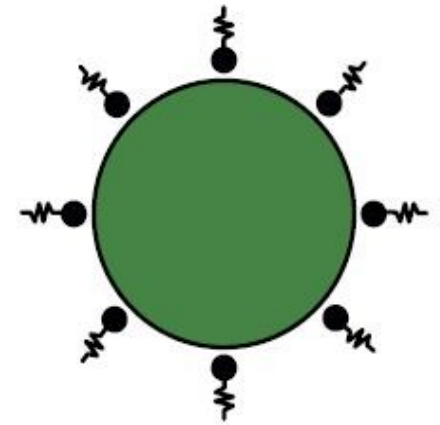
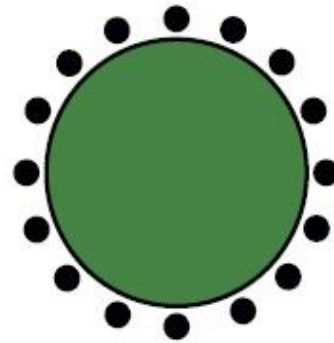
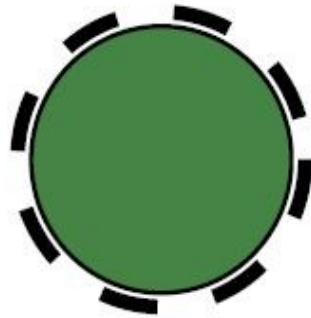
Motivation

- Many shape deformations result in artifacts[2]
- Why are conformal changes interesting?
 - Isotropic conductivities remain isotropic and do not introduce artifacts [3]
- ... but is this true for all electrode models?
 - We compare electrode model behaviour when the body is deforming, in simulation

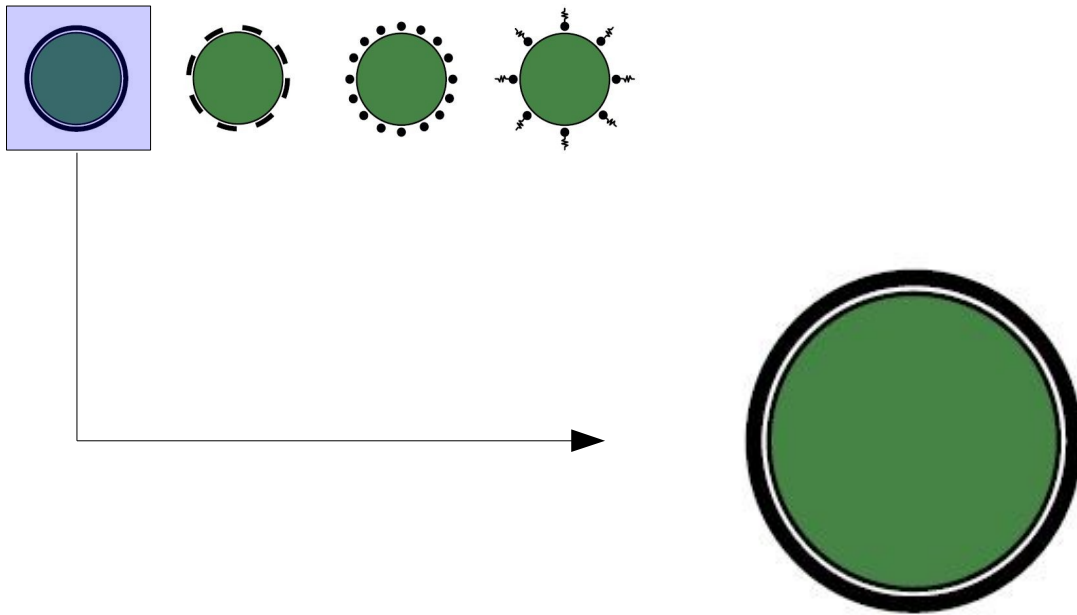
[2] A Adler et al, *Impedance imaging of lung ventilation: do we need to account for chest expansion?*, 1996, IEEE BME

[3] WRB Lionheart, *Boundary Shape and Electrical Impedance Tomography*, 1998, IOP Journal Inv. Problems

Mathematical Electrode Models

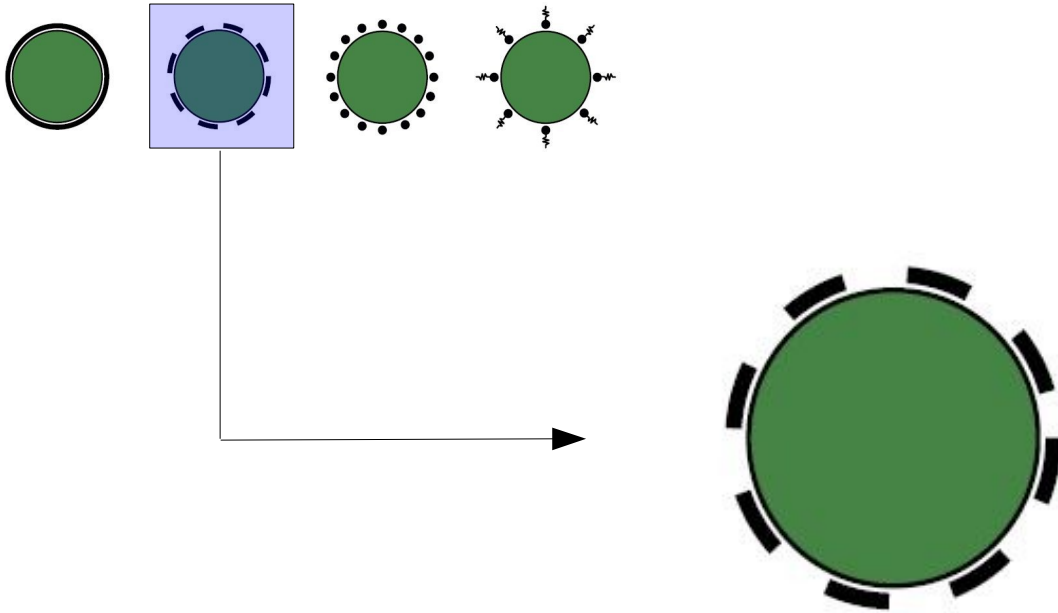


Mathematical Electrode Models



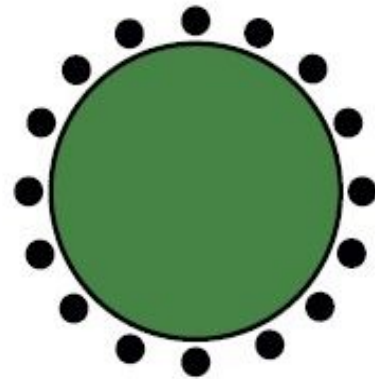
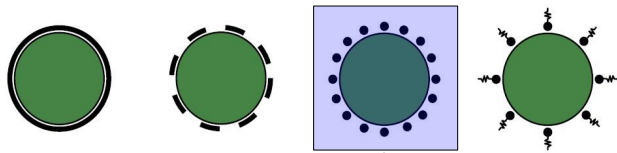
Continuous Model

Mathematical Electrode Models



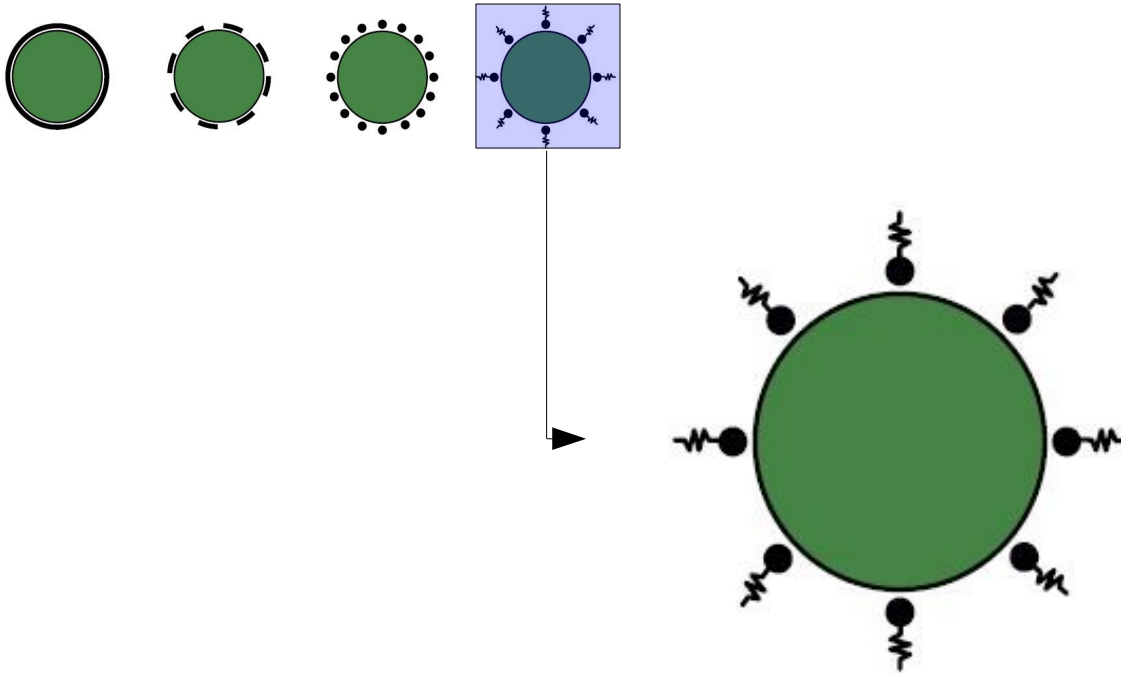
Gap Model

Mathematical Electrode Models



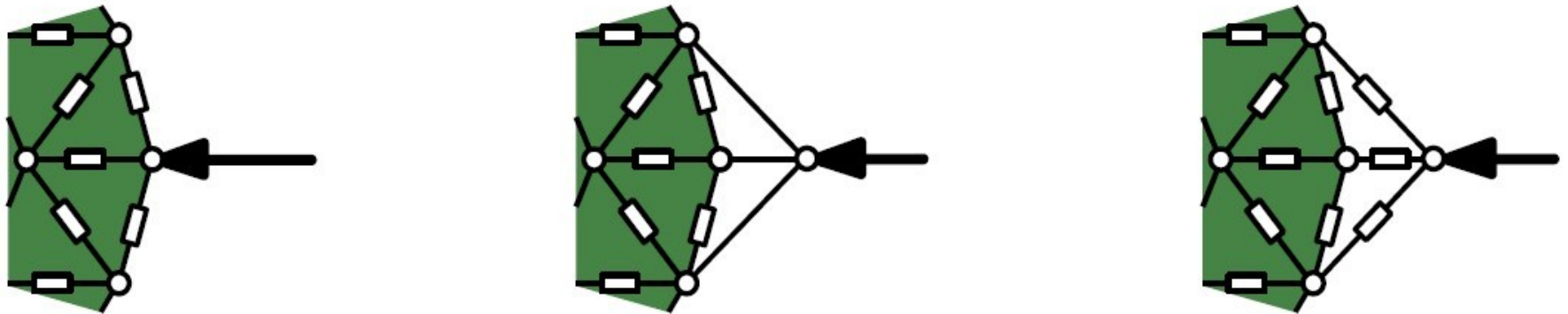
Shunt Model

Mathematical Electrode Models

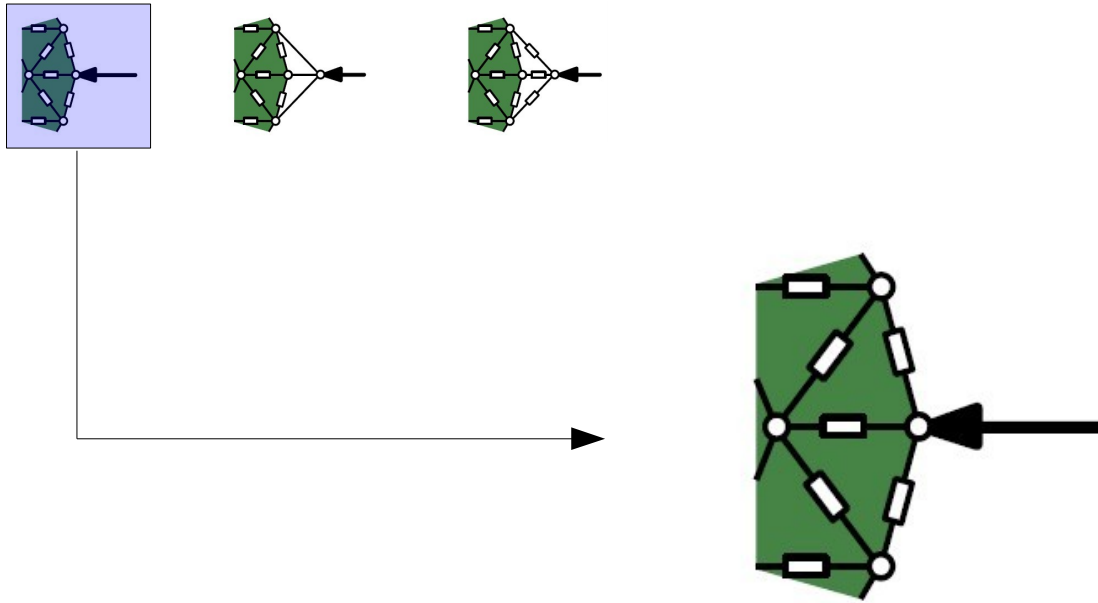


Complete Electrode Model

Finite Element Method Electrode Models

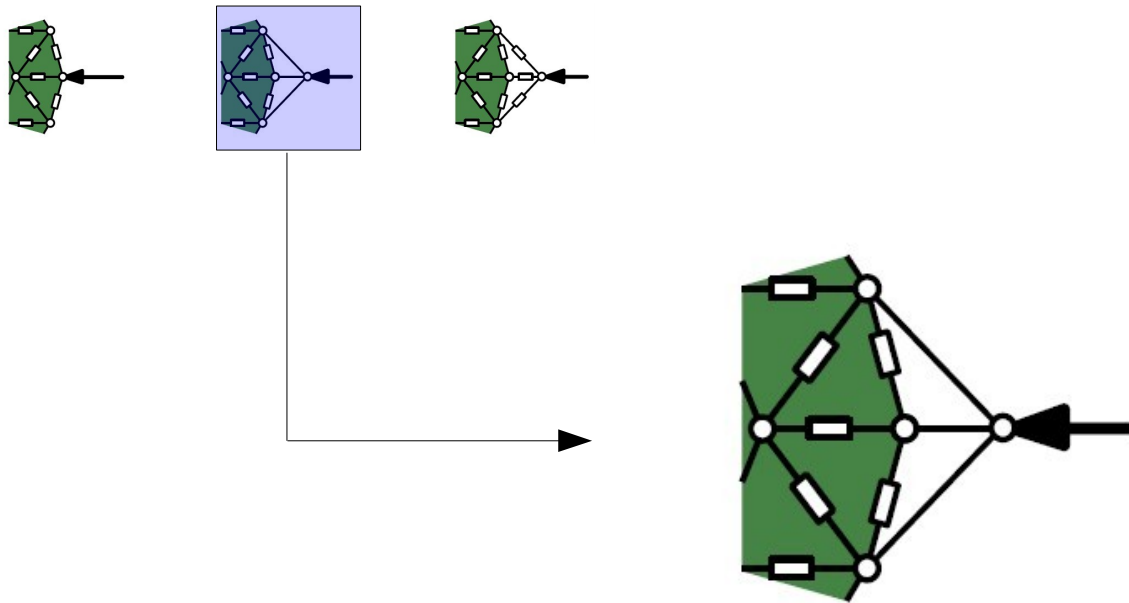


Finite Element Method Electrode Models



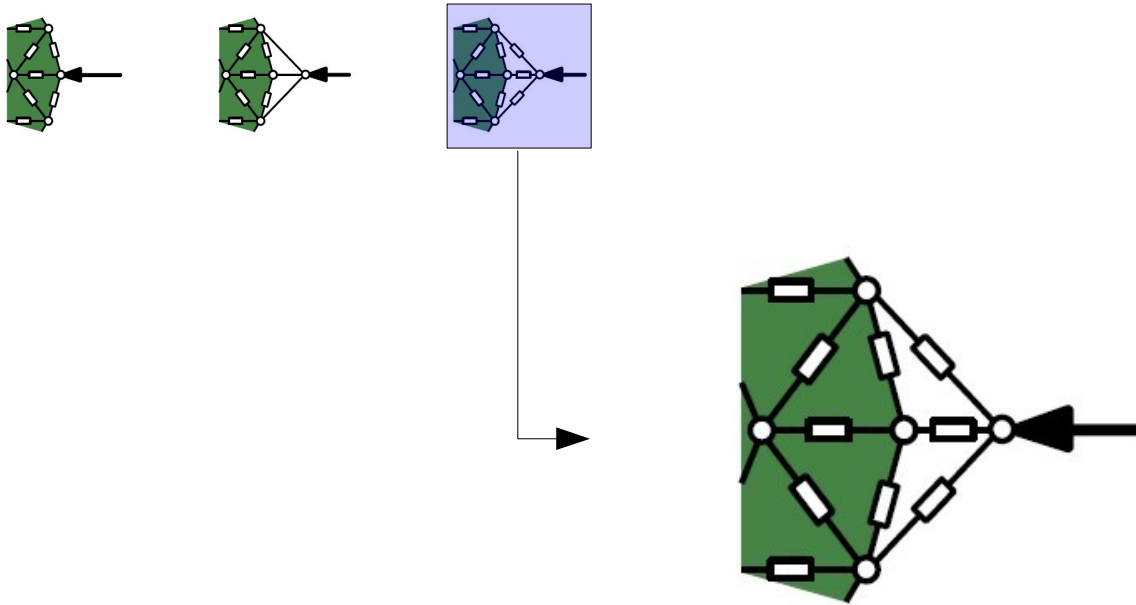
Point Electrode Model

Finite Element Method Electrode Models



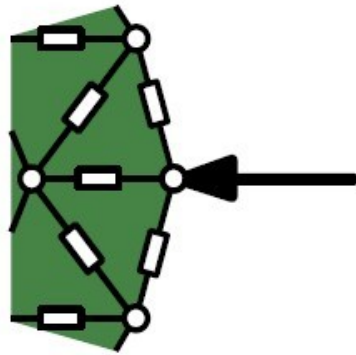
Shunt Electrode Model

Finite Element Method Electrode Models

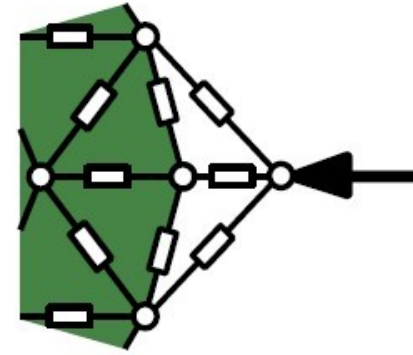


Complete Electrode Model

Focus



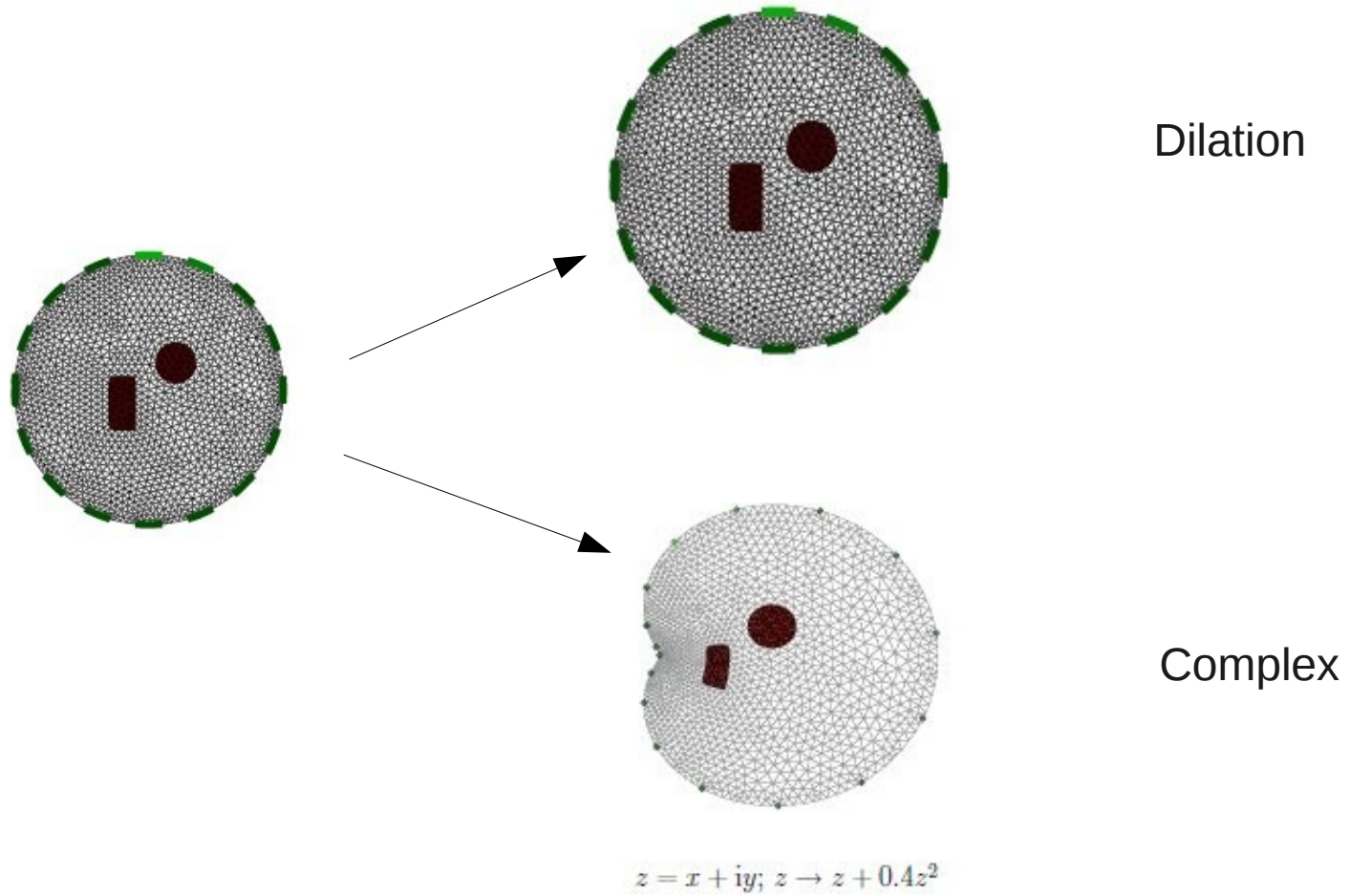
Point
Electrode Model
(PEM)



Complete
Electrode Model
(CEM)

- With respect to conformal deformations:
 - PEM does not introduce artifacts.
- What about CEM?

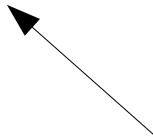
Conformal Deformations



Electrode Deformation

Table 1 : Electrode Model Behaviour under Deformation

Model	Deformation		AAM _n	Comment
	Domain	Electrode		
PEM	dilation	matching	0	
	complex		0.0807	
	dilation	fixed	0	
CEM	dilation	matching	0.0010	
	complex		2.013	artifacts (deformed)
	dilation	fixed	5.5	artifacts (ringing)


$$\text{AAM}_n = \sum \left[\frac{c_1 - c_0}{c_0} \right]^2$$

Electrode Deformation and Contact Impedance

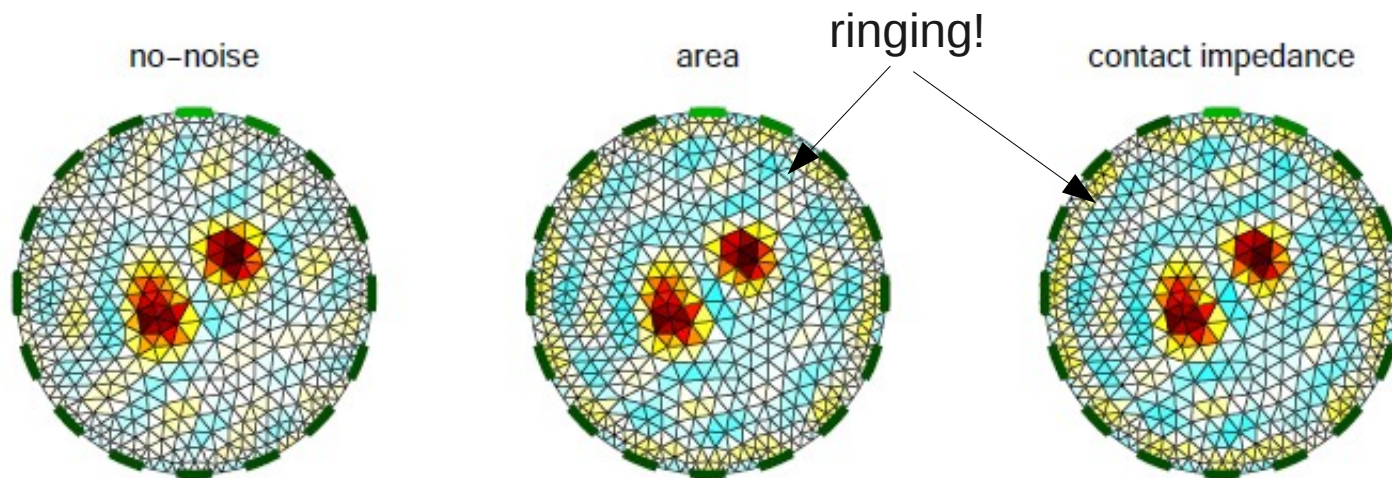
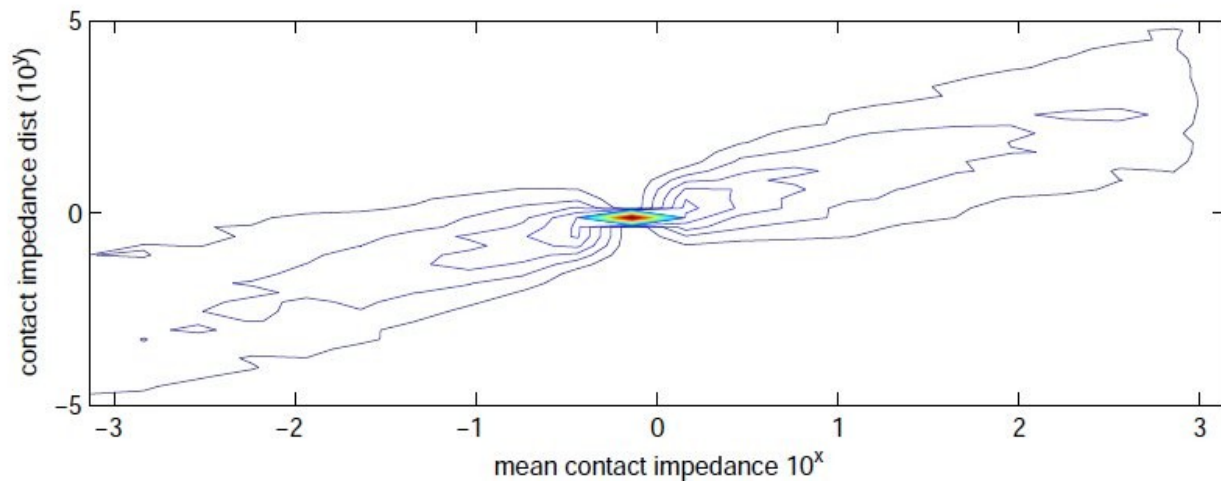
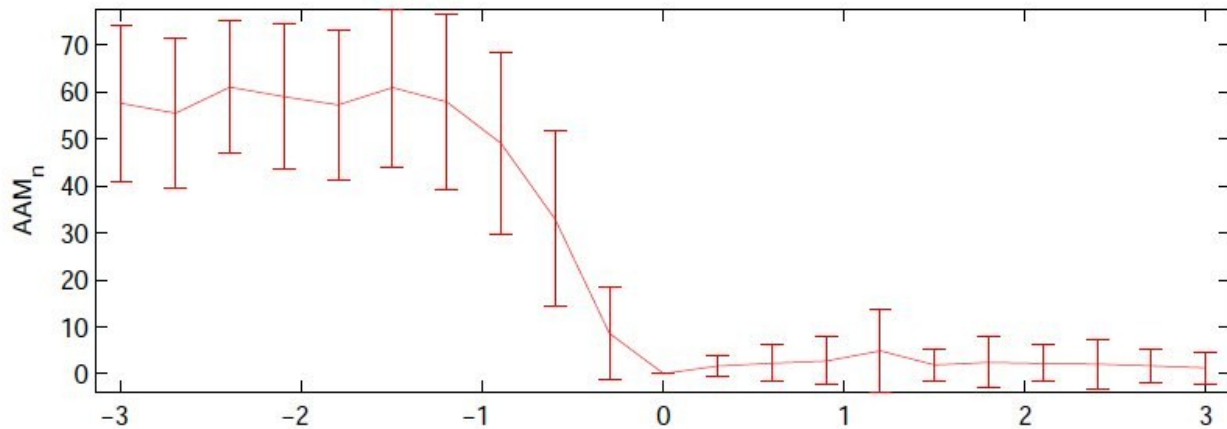


Figure 10.4: Electrode area versus contact impedance artifacts: (left) reconstruction, no noise; (middle) reconstruction, electrode areas reduced to $1/4$, $AAM_n = 5.5$; (right) reconstruction, contact impedances reduced to $1/16$, $AAM_n = 7.04$

Electrode Contact Impedance

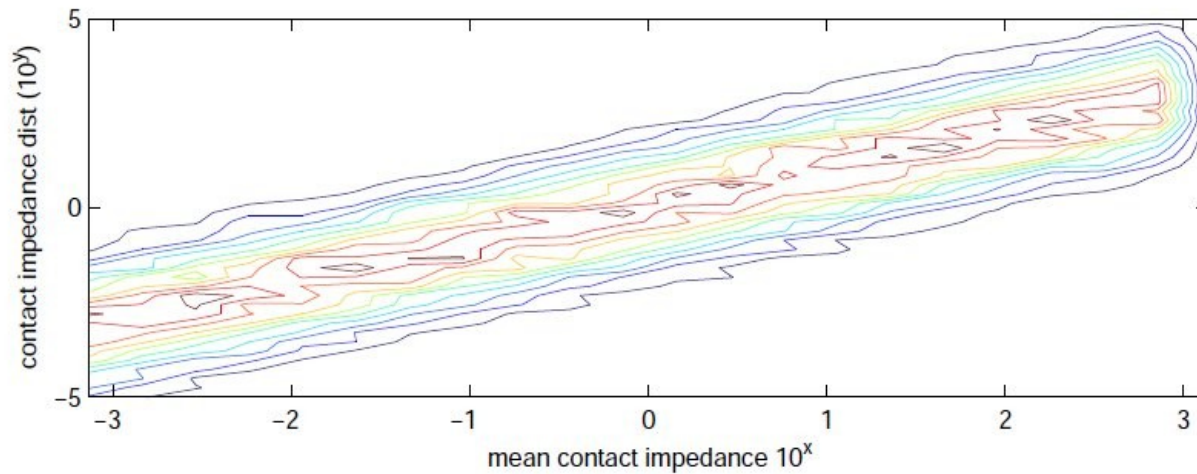
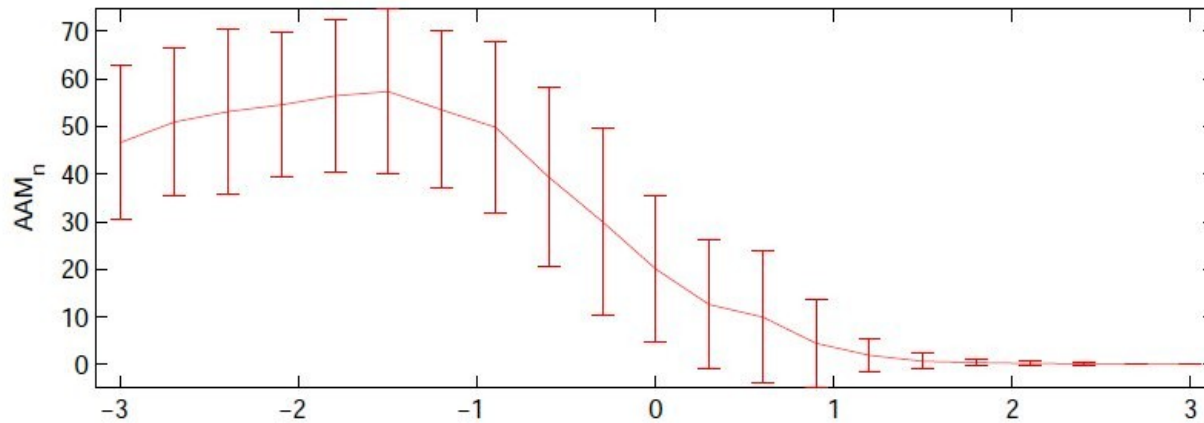


$$z_c = 10^{\mathcal{N}(\mu, \sigma^2)}$$

$$3 \leq \mu \leq 3$$

$$\sigma^2 = |\mu|$$

Electrode Contact Impedance



$$z_c = 10^{\mathcal{N}(\mu, \sigma^2)}$$

$$3 \leq \mu \leq 3$$

$$\sigma^2 = 1$$

Discussion:

Electrode Models under Shape Deformation

- Using the CEM, reconstructions of conformal deformations can result in artifacts
- Changes in contact impedance and electrode area can result in similar artifacts
- Increases in contact impedance do not result in reconstruction artifacts

Thank You

Questions?